

REMARKS

Claims 1-6, 8-10, 13, 15-17, and 22 are rejected under 35 U.S.C. 102(b) as being anticipated by Kim et al., U.S. 5,003,357 (hereinafter "Kim"). Applicants respectfully traverse the rejection. Claim 1 recites "a mount comprising: a body comprising silicon, the body having a substantially flat surface, and a quantity of material attached to the substantially flat surface of the body, the quantity of material forming a wall."

In contrast, Kim's device includes a light emitting device mounted in a trench formed in a Si substrate. For example, column 2 lines 8-25 of Kim state "when the Si-substrate 2 has a <100> surface plane, the V-groove can be etched through the patterned SiO₂ mask 21 in KOH solution at 80 °C or by alternative methods. For the pattern aligned to the $\overline{110}$ or <110> direction, the angle of etched V-groove is about 54° with respect to the substrate plane. . . . Then the light emitting device 1 is mounted on the bottom side of the groove of the silicon substrate 2 using Sn solder, Ag paste or some other electrically conductive materials."

Accordingly, Kim's device does not have a body with a substantially flat surface and a quantity of material attached to the substantially flat surface to form a wall, as recited in claim 1, because Kim's substrate 2 includes a trench, and thus does not have a substantially flat surface. Kim thus does not teach all the elements of claim 1; therefore, claim 1 is allowable over Kim.

Claims 2-6, 8-10, 13, 15-17, and 22 depend from claim 1 and are therefore allowable over Kim for at least the same reason as claim 1. In addition, regarding claim 8, Applicants can find no teaching in Kim of "whercin the reflective layer comprises a dielectric stack." The Examiner cites Kim's passivation layer 11 as being claim 8's dielectric stack, however Applicants can find no teaching in Kim that passivation layer 11 is reflective, and since passivation layer 11 is covered by metal layer 9, a person of skill in the art would not expect

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any light to reach passivation layer 11 through metal layer 9. Claim 8 is thus allowable over Kim for this additional reason. Regarding claim 10, since Kim does not teach claim 1's quantity of material, Applicants fail to see how Kim could teach wherein the "quantity of material comprises one of BCB, PMMA, photoresist, polyamides, glass, spin-on-glass, Al, Ag, Au, Pt, Pd, In, Ni, and Cr" as recited in claim 10. Claim 10 is thus allowable over Kim for this additional reason. Regarding claims 16 and 17, Applicants have found no teaching in Kim of "a quantity of second material disposed between the device and the wall." Claims 16 and 17 are thus allowable over Kim for this additional reason.

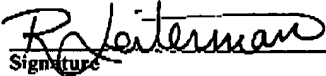
Claims 7, 11, 12, 14, and 18-21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kim in view of Ishinaga U.S. 6,355,946 and Ishinaga U.S. 6,593,598. Applicants respectfully traverse the rejection. Applicants have found no teaching in either Ishinaga reference of "a mount comprising a body comprising silicon" as recited in claim 1. Regarding the specific elements of Ishinaga cited by the Examiner, these elements add nothing to the deficiencies of Kim with respect to claim 1, thus claims 7, 11, 12, 14, and 18-21 are allowable over Kim, Ishinaga, and Ishinaga for at least the same reason claim 1 is allowed over Kim. Regarding claim 21, Applicants respectfully dispute the Examiner's statement that "the epoxy in Ishinaga (US-6,593,598 B2) inherently has an index of refraction between about 1.4 and 1.7." A person of skill in the art would know that the index of refraction of epoxies may vary greatly and may be less than 1.4.

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In view of the above arguments, Applicants respectfully request allowance of claims 1-22. Should the Examiner have any questions, the Examiner is invited to call the undersigned at (408) 382-0480.

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Respectfully submitted,



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